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## \*BIBDATASHEET\*

Bib Data Sheet

CONFIRMATION NO. 4139

SERIAL NUMBER 09/428,052	FILING DATE 10/27/1999  RULE	CLASS 438	GROUP ART UNIT 2815	ATTORNEY DOCKET NO. 970901A	
APPLICANTS  KIYOSHI IRINO, KAWASAKI-SHI, JAPAN;  ** CONTINUING DATA ***** This application is a DIV of 08/917,936 08/27/1997 PAT 5,990,517 <i>D</i>  ** FOREIGN APPLICATIONS ***** JAPAN 9-052085 03/06/1997 <i>D</i>  IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 11/24/1999					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>Examiner's Signature</i> <i>Initials</i>		STATE OR COUNTRY JAPAN	SHEETS DRAWING 12	TOTAL CLAIMS 8	INDEPENDENT CLAIMS 1
ADDRESS 23850 ARMSTRONG, WESTERMAN & HATTORI, LLP 1725 K STREET, NW SUITE 1000 WASHINGTON, DC 20006					
TITLE METHOD OF FABRICATING A SEMICONDUCTOR DEVICE CONTAINING NITROGEN IN A GATE OXIDE FILM					
FILING FEE  RECEIVED 760	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input checked="" type="checkbox"/> All Fees <input checked="" type="checkbox"/> 1.16 Fees ( Filing ) <input checked="" type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input checked="" type="checkbox"/> 1.18 Fees ( Issue ) <input checked="" type="checkbox"/> Other _____ <input checked="" type="checkbox"/> Credit		